

In re application of: MERRITT FUNK

Application No.:

Confirmation

No:

Filed: June 30, 2003

Group No.:

Examiner

For: FEEDFORWARD, FEEDBACK WAFER TO WAFER CONTROL METHOD FOR AN ETCH PROCESS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: MERRITT FUNK
Citizenship: USA
Residence: Austin, TX

2. Correspondence information

Correspondence for this application should be addressed as follows:

Dale S. Lazar, Pillsbury Winthrop LLP
P.O. Box 10500
McLean, VA 22102
Customer No.: 00909

3. Application information

Title of Invention: FEEDFORWARD, FEEDBACK WAFER TO WAFER CONTROL METHOD FOR AN ETCH PROCESS

Docket number assigned to this application: 071469-0304316

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 3

Type of application:

Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Dale S. Lazar, Pillsbury Winthrop LLP
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5. Assignee information


The assignee(s) of this application is/are:

Tokyo Electron Limited
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Extent of interest of assignee in application: 100%

Date: June 30, 2003

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Signature of Practitioner
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